	Application No.	Applicant(s)	
	Application No.	Applicant(s)	$\langle \omega \rangle$
Nadia a se Allanos bilita	10/662,436	LIM ET AL.	(CM)
Notice of Allowability	Examiner	Art Unit	
	Toan Ton	2871	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED in the community of	his application. If not include ication will be mailed in due of	d course. THIS
1. This communication is responsive to papers filed 02/28/05.			
2. ☑ The allowed claim(s) is/are <u>1-16</u> .			
3. $\boxtimes$ The drawings filed on <u>16 September 2003</u> are accepted by	the Examiner.		
4.  Acknowledgment is made of a claim for foreign priority una a)  All b)  Some* c)  None of the:  1.  Certified copies of the priority documents have  2.  Certified copies of the priority documents have  3.  Copies of the certified copies of the priority documents have  International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DATE" on the below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  5.  A SUBSTITUTE OATH OR DECLARATION must be subministed in the subministed part of the priority of the Notice of Draftspers  1)  hereto or 2)  To Paper No./Mail Date  (b)  including changes required by the Notice of Draftspers  Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the propagation of the priority unit is not the deposit attached Examiner's comment regarding REQUIREMENT in the propagation of the priority unit is not to provide the deposit the deposit of the priority documents have a priority documents have a priority document the deposit of the priority documents have a priority document the deposit of the priority documents have a priority document	been received.  been received in Application cuments have been received in Application of this communication to file at ENT of this application.  itted. Note the attached EXAMES reason(s) why the oath or communication to file at the submitted.  In the submitted is Amendment / Comment or in the header according to 37 CFR sit of BIOLOGICAL MATER	No. 09/864,149. In this national stage applicate reply complying with the requirement of the complex of the office action of drawings in the front (not the 1.121(d).  RIAL must be submitted. No	uirements OTICE OF
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	6. Interview Sur Paper No./M 7. Examiner's A	lail Date mendment/Comment tatement of Reasons for Allo	

## REASONS FOR ALLOWANCE

## 1. Claims 1-9 are allowed.

The following is an examiner's statement of reasons for allowance: the prior art of record does not anticipate nor render obvious to one ordinary skilled in the art an active matrix (TFTs) liquid crystal display device comprising a combination of various elements as claimed, more specifically, a connecting pattern having an open portion between the drain electrode of the TFT and the data line, the open portion electrically disconnects the drain electrode from the data line, a portion of the color filter being in direct contact with the pixel electrode, the connecting pattern is used for electrodepositing the color filter layer on the pixel electrode.

Izumi ('898) discloses an active matrix (TFTs) liquid crystal display device comprising a drain electrode, a data line, a portion of the color filter being in direct contact with the pixel electrode. However, Izumi fails to disclose 'a connecting pattern having an open portion between the drain electrode of the TFT and the data line, the open portion electrically disconnects the drain electrode from the data line, the connecting pattern is used for electrodepositing the color filter layer on the pixel electrode'.

Ohtsu ('486, '772) and Matsushima ('079) disclose method of electrodepositing a color filter layer. However, none discloses 'a connecting pattern having an open portion between the drain electrode of the TFT and the data line, the open portion electrically disconnects the drain electrode from the data line, a portion of the color filter being in direct contact with the pixel electrode, the connecting pattern is used for electrodepositing the color filter layer on the pixel electrode'.

Application/Control Number: 10/662,436 Page 3

Art Unit: 2871

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## **CONTACT INFORMATION**

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toan Ton whose telephone number is (571) 272-2303.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

March 10, 2005

TOANTON PRIMARY EXAMINER